

<b>Notice of References Cited</b>	Application/Control No. 10/688,281	Applicant(s)/Patent Under Reexamination YUN ET AL.	
	Examiner A. Dexter Tugbang	Art Unit 3729	Page 1 of 1

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*	B	US-6,334,244	01-2002	Hashizume, Tsutomu	29/25.35
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	K	US-			
	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.